



ELECTRONIC COPY

LG791601670
Report verification at igi.org



May 15, 2026
IGI Report Number **LG791601670**
Description **LABORATORY GROWN DIAMOND**
Shape and Cutting Style **CUT CORNERED
RECTANGULAR MODIFIED
BRILLIANT**
Measurements **10.11 X 7.26 X 4.97 MM**
GRADING RESULTS
Carat Weight **3.03 CARATS**
Color Grade **E**
Clarity Grade **VS 1**

LABORATORY GROWN DIAMOND REPORT

May 15, 2026
IGI Report Number **LG791601670**
Description **LABORATORY GROWN DIAMOND**
Shape and Cutting Style **CUT CORNERED RECTANGULAR
MODIFIED BRILLIANT**
Measurements **10.11 X 7.26 X 4.97 MM**

GRADING RESULTS

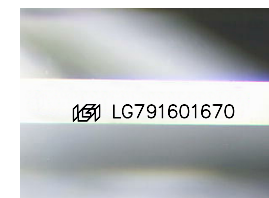
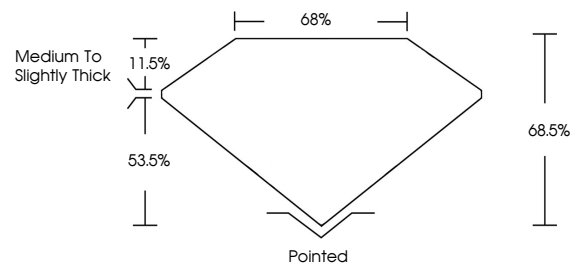
Carat Weight **3.03 CARATS**
Color Grade **E**
Clarity Grade **VS 1**

ADDITIONAL GRADING INFORMATION

Polish **EXCELLENT**
Symmetry **EXCELLENT**
Fluorescence **NONE**
Inscription(s) **IGI LG791601670**

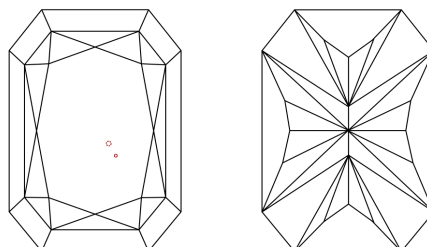
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa

PROPORTIONS



Sample Image Used

CLARITY CHARACTERISTICS



KEY TO SYMBOLS

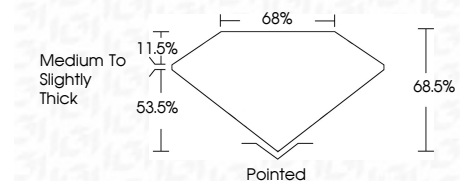
Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.

COLOR

D E F G H I J Faint Very Light Light

CLARITY

| FL | IF | VS ¹⁻² | VS ¹⁻² | SI ¹⁻² | I ¹⁻³ |
|----------|---------------------|-----------------------------|------------------------|-------------------|------------------|
| Flawless | Internally Flawless | Very Very Slightly Included | Very Slightly Included | Slightly Included | Included |



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IGI



May 15, 2026
IGI Report No LG791601670
CUT CORNERED RECT. MODIFIED BRILLIANT
10.11 X 7.26 X 4.97 MM
3.03 CARATS
E
VS 1
68.5%
53.5%
11.5%
Medium to Slightly Thick
Pointed
EXCELLENT
EXCELLENT
NONE
IGI LG791601670
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa